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By: 

Theresa E. Limes

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

INVENTOR(S) : Rajasingh Israel, et al.

TITLE : OPTIMAL SILICON DIOXIDE PROTECTION  
LAYER THICKNESS FOR SILVER LAMP  
REFLECTOR

APPLICATION NO. : 10/633,085

FILED : August 1, 2003

CONFIRMATION NO. : 3209

EXAMINER : Anne M. Hines

ART UNIT : 2879

LAST OFFICE ACTION : November 2, 2007

ATTORNEY DOCKET NO. : LD HQ10695-3  
GECZ 2 00083-2-3

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT A**

Dear Sir:

Responsive to the Office Action mailed November 2, 2007, on the above- referenced patent application, Applicant(s) respectfully request reconsideration of the application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.